



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re	Patent	Application	of:
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Taketomi ASAMI et al.

Serial No. 09/842,315

Filed: April 26, 2001

For: MANUFACTURING METHOD FOR

SEMICONDUCTOR DEVICE

) Group Art Unit: 2813

) Examiner: D. Blum

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on March 3,

Rollin Stamper

2004.

AMENDMENT

Honorable Commissioner of Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In response to the Official Action dated November 3, 2003, please consider the following amendments and remarks in connection with the above-identified application.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 7 of this paper.